

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani et al.                      Art Unit : 2815  
Serial No. : 09/379,702                                      Examiner : Eugene Lee  
Filed : August 24, 1999                                      Conf. No. : 1613  
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR ORAL HEARING

Under the provisions of 37 CFR §41.47(b), appellant respectfully requests an oral hearing. The fee in the amount of \$1000 in payment of the oral hearing request fee of §1.17(p) is being paid concurrently herewith on the Electronic Filing System (EFS) by way of Deposit Account authorization. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: Sept. 6, 2006

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